

## UNITED STATES DEPARTMENT OF COMMERCE Patent and Trademark Office Address: COMMISSIONER OF PATENTS AND TRADEMARKS Washington, D.C. 20231

APPLICATION NO. FILING DATE	FIRST NAMED INVENTOR	~	ATTORNEY DOCKET NO.
39/139.296 03/25/98	on region		.704 101
_ OLIFE & BERRIDGE, PLC	00171/8422		
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ALEXANDRIA VA 22320		ART UN	T PAPER NUMBER
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Please find below and/or attached an Office communication concerning this application or proceeding.

Commissioner of Patents and Trademarks

PTO-90C (Rev. 2/95) 1- File Copy

## Application No. | Application

Applicant(

Ohtomo et al

Office Action Summary

Examiner Mr. Shival P. Virmani Group Art Unit 2852

Responsive to communication(s) filed on	
☐ This action is FINAL.	
☐ Since this application is in condition for allowance except in accordance with the practice under Ex parte Quayle, 1	
A shortened statutory period for response to this action is s is longer, from the mailing date of this communication. Fail application to become abandoned. (35 U.S.C. § 133). Exte 37 CFR 1.136(a).	
Disposition of Claims	
X Claim(s) 28-31	is/are pending in the application.
Of the above, claim(s)	is/are withdrawn from consideration.
Claim(s)	is/are allowed.
X Claim(s) 28-31	is/are rejected.
Claim(s)	is/are objected to.
	are subject to restriction or election requirement.
Application Papers	
See the attached Notice of Draftsperson's Patent Draft	wing Review, PTO-948.
The drawing(s) filed on is/are ob	ejected to by the Examiner.
The proposed drawing correction, filed on	is approved disapproved.
The specification is objected to by the Examiner.	
The oath or declaration is objected to by the Examine	г.
Priority under 35 U.S.C. § 119	
X Acknowledgement is made of a claim for foreign prior	rity under 35 U.S.C. § 119(a)-(d).
	s of the priority documents have been
received.	
received in Application No. (Series Code/Serial	·
received in this national stage application from	the International Bureau (PCT Rule 17.2(a)).
*Certified copies not received:	
Acknowledgement is made of a claim for domestic pr	iority under 35 U.S.C. § 119(e).
Attachment(s)	
X Notice of References Cited, PTO-892	
Information Disclosure Statement(s), PTO-1449, Pape     Information Symmotry, PTO 413	r No(s)4
<ul> <li>Interview Summary, PTO-413</li> <li>Notice of Draftsperson's Patent Drawing Review, PTO</li> </ul>	1.948
☐ Notice of Informal Patent Application, PTO-152	, 040
SEE OFFICE ACTION O	ON THE FOLLOWING PAGES

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## DETAILED ACTION

## Claim Rejections - 35 USC § 102

 The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless --

- (e) the invention was described in a patent granted on an application for patent by another filed in the United States before the invention thereof by the applicant for patent, or on an international application by another who has fulfilled the requirements of paragraphs (1), (2), and (4) of section 371 © of this title before the invention thereof by the applicant for patent.
- 2. Claims 28-31 are all rejected under 35 USC § 102(e) as being anticipated by Ohtomo et al (5, 850, 280). Regarding these claims, Ohtomo et al discloses a lithographic device comprising a substrate stage (20 and 21) which can be positioned by a first positioning device (25 or 27) parallel to a y-direction (stage 21) which is perpendicular to a vertical z-direction and an x-direction which is perpendicular to the y and z directions (stage 20), an imaging system (1-4) with a main axis parallel to the z-direction, a mask stage (8 and 9) which can be positioned parallel to the y-direction (see col. 6, lines 37-42) by a second positioning device (linear motor) and an illumination optical system (14) which irridates an exposure illumination light beam. Further, Ohtomo et al discloses that the mask stage (8 and 9) is positionable parallel to the x-direction (col. 6, lines 37-41) and rotatable about an axis of rotation (theta) which is parallel to the z-direction (see col. 7, lines 38-42) by the second positioning device (note: the actuators, which move the mask stage in both the x and y directions also move said stage relative to the axis of rotation--the axis parallel to the z-direction; again, please see col. 7, lines 15-42). Finally,

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Ohtomo et al teaches that the second positioning device is provided with a first linear motor (31A or 31B) by which the mask stage can be positioned over comparatively small movement parallel to the x and y directions (note: a small or heavy thrust can be used depending on the desired movement; see col. 7, lines 50-59) and can be rotated about the axis of rotation of the mask stage (see above) and a second linear motor (31B) which can position the mask stage over comparatively greater distances parallel to the y-direction (see col. 9, lines 48-50, where the actuators associated with the x-direction movement have a smaller thrust force than those actuators used for y-direction movement).

 Any inquiry concerning this communication or earlier communications from the examiner should be directed to Mr. Shival P. Virmani whose telephone number is (703) 308-1050.

S.V.

April 19, 1999

Richard Moses Primary Examiner

P L. moses